

<b>Notice of References Cited</b>	Application/Control No. 10/027,720	Applicant(s)/Patent Under Reexamination GASPARIK, FRANK	
	Examiner Kim T. Huynh	Art Unit 2112	Page 1 of 1

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	B	US-6,445,245 B1	09-2002	Schultz et al.	327/541
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	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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